## **AMENDMENTS TO THE ABSTRACT**

On page 39, after the claims, please insert the following text shown in underline:

## ABSTRACT OF THE DISCLOSURE

Apparatus and methods in accordance with implementations of the present invention can be configured for cleaning at least one process chamber, which in turn is configured for coating at least one substrate. In general, the at least one substrate will be made from glass, and the at least one process chamber can be purged with a conditioned purge gas prior to a coating operation.